

U.S. Patent Application No. 10/518,704  
Response to Office Action mailed May 18, 2007**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Tetsuo YAMADA, et al.

Serial No. : 10/518,704

For : THIN FILM PIEZOELECTRIC RESONATOR, THIN  
FILM PIEZOELECTRIC DEVICE, AND  
MANUFACTURING METHOD THEREOF (As Amended)

Filing Date : December 17, 2004

Examiner : Mark Osborne Budd

Group Art Unit : 2834

Confirmation No. : 5674

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June 14, 2007.

Ronald R. Santucci, Reg. No. 28,988

(Name of Applicant, Assignee or Registered Representative)

Signature

June 14, 2007

Date of Signature

**AMENDMENT**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated May 18, 2007, setting a two-month period  
for response ending July 18, 2007, Applicants respectfully request that the application be further  
amended as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks** begin on page 17 of this paper.